

<b>Notice of References Cited</b>	Application/Control No. 10/717,617	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Helen C. Kwok	Art Unit 2856	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,131,457	10-2000	Sato, Kaoru	73/514.31
	C	US-			
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	I	US-			
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	S					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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